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Functional Specification

DRAFT

MEASUREMENT OF THE LHC BEAM TRANSVERSE DISTRIBUTION

Abstract

The present specification provides the functional requirements of the monitors that will measure the transverse distributions of the LHC beams. Beam intensities ranging from a single pilot bunch up to ultimate circulating current in both rings should be covered.

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1. SCOPE

The present specification provides the functional requirements of the monitors that will measure the transverse distribution of the LHC beams.

A large dynamic range is to be covered to extract the relevant information from tail distributions up to more basic data related to the nominal beam distribution, (centre of gravity, edges, width, shape).

Concerning the integration time and integration mode, a bandwidth extending from the bunch frequency (40 MHz), up to integration on several beam revolutions (< 11kHz) is to be covered. The sampling time may be related to the investigated amount of current.

Nominal parameters foreseen for proton operation are usually considered but ion operation must also be covered. Concerning ions, the nominal bunch charge will vary, depending on the species, from 5 10^9 charges for Pb ions, which is also the proton pilot bunch charge, to nearly the proton nominal bunch charge of 1.1 10^{11} (O ions). Moreover, 608 ion bunches spaced by 125 ns are foreseen to compose a nominal beam.

Transverse beam distributions will be measured:

- in the transfer lines between the injector (SPS) and the LHC
- at injection into the LHC.
- on the first turn as well as on consecutive turns around the machine.
- when a beam circulates in one ring or when both beams are colliding. In this mode one may have to deal with a single bunch or with selected bunches or batches.
- in the dump lines when any kind of beam is extracted from one ring to the dump absorber.

2. DESCRIPTION OF THE OBSERVABLES

Different kinds of primary observables [1] are used depending on the application. Photons emitted by the beam (synchrotron radiation, optical transition radiation) or a signal coming from the medium traversed by the beam (secondary emission, nuclear reactions, ionisation) can be investigated.

The variation of one of these primary observables analysed in a plane perpendicular to the beam trajectory at a given azimuth of the machine circumference, provides the beam transverse distribution at the signal source. This is performed in the horizontal and in the vertical directions. The beam transverse distribution along these directions, or transverse profile, is the beam observable.

3. DESCRIPTION OF THE RELATED BEAM PARAMETERS

The parameters related to transverse beam profiles are:

- the average beam position
- the rms value of the distribution or beam size
- the edges of the distribution
- the distribution integral or norm
- the distribution of low intensity tails
- the tilt with 2D images (beam transverse cross-section)
- the beam emittance

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- the beam energy spread
- higher order momenta, for example the skewness

4. DESCRIPTION OF THE DIFFERENT USES.

Figure 1 describes the time structure of the nominal LHC beam.



Figure 1: Bunch pattern in the LHC machine.

$4.1\,$ TRANSFER LINES BETWEEN THE SPS AND THE LHC AND INJECTION INTO THE LHC

Transverse beam size measurement requirements in the transfer lines and at injection are analysed elsewhere [2]: at injection into the LHC, one monitor is needed at the injection septa and another one at the injection kickers to verify the beam position at these locations and check the correct functioning of the devices. Some redundancy in such a critical area is desirable and justifies the duplication, (upstream and downstream each of the two magnet families) of these monitors. Another monitor is requested in front of the TDI absorber.

Another monitor is proposed downstream the insertion to check how the beam behaves after having travelled through the first arc of the ring. It can be positioned between quadrupoles Q7 and Q6, i.e. before the dogleg and the first collimators of the cleaning insertion.

Table 1 summarises the requirements on the positioning of the monitors. The total number of monitors is 11, preferably 13, per injection line. Details of the proposed positions in the line TI2 and TI8 and on measurement tolerances are given in [2].

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Location	No. of monitors	Main use	
Before first TED	3	Beam quality at line entrance: common with CNGS line in the case of TI8.	
Centre of line	3	Measurements in the regular FODO cells	
Before last TED	1	Beam quality at entrance of the LHC ring.	
LHC injection septa and kickers	2, preferably 4	Beam position in and functional check of injection devices.	
TDI	1	Adjustment of TDI.	
Between Q7 and Q6 after first arc cryostat	1	Look at first turn trajectory	

Table 1 : Location and number of monitors required for each transfer line.

When a train of bunches is transferred, the measurement can be integrated over the whole batch. Precision determinations of the beam optics will be performed with single bunches. Although not strictly necessary, the possibility to select the profile of a bunch (or of several selected bunches) inside a batch should be evaluated as an extra asset.

4.2 MEASUREMENT ON THE FIRST TURNS

4.2.1 USES AND LOCATION

Before a closed orbit is fully established, transverse profile measurements are useful, to check roughly how an injected beam circulates around the machine. This permits:

- to identify a possible aperture restriction, by looking at the signal evolution from turn to turn
- to detect a source of blow-up (rms value).

These preliminary checks must be made carefully and with a pilot bunch, in order to limit the risk of a quench in one of the super-conducting magnet units. The installation of dedicated first turn study TV screens around the rings is not fully justified. However additional TV stations will be available in LSS4, for matching studies, and in LSS6, to adjust the beam extraction to the dump, see sections 4.3.3 and 4.4. They could be employed for injection studies.

4.2.2 TOLERANCES

An accuracy and a resolution of 10% are expected at this stage on the rms value, which is close to 1 mm at 450 GeV

4.3 CIRCULATING BEAM(S)

4.3.1 USES

When circulating beam conditions are established, the beam current can be increased progressively up to the population of a nominal bunch. The beam transverse distributions are measured using non-interceptive devices and with adequate sampling times.

One important application is the progressive tuning with increasing current of the collimation system and of the various absorbers. For this application, the question of the need of dedicated profile monitors in the cleaning insertions must be clarified.

The other studies to perform are:

- □ when several bunches are injected, the verification of the injection conditions: stability between bunches, reproducibility between batches.
- □ the injection matching conditions optimisation, by looking at the modulation of the rms values over consecutive turns after injection [3]. This adjustment can be started with a single bunch, using a dedicated TV monitor and then refined with passive monitors on the nominal beam.
- □ Loss mechanisms and visual checks of optics and coupling, (with 2D images).
- Bunch to bunch or batch to batch differences (average position, rms value).
- □ Presence of tails, 10⁻³ down to less than 10⁻⁴ the maximum of the bunch distribution, up to distances of 5 rms values from the average position, first at 450 GeV, then during the ramp and at top energy (shape). This study can be performed by integration on several hundreds of turns.
- Dynamic aperture determination (rms, edges, shape).
- Beam size / emittance control at 450 GeV and during the ramp and squeeze processes (rms value)
- □ in the case of ions, to detect any intra beam scattering effect affecting the bunch shape.
- Apart from injection optimisation, the same studies are relevant once the beams are colliding at top energy. In addition, when several bunches circulate in each beam, the differences between bunch species, (average position, rms value, shape), is reinforced under the influence of beam-beam effects. Hence, bunch to bunch discrimination is important to be able to distinguish between bunch families.

4.3.2 TOLERANCES

Accuracy and resolution of 4% are needed on the determination of the beam transverse dimensions under nominal conditions. In particular, this is useful to adjust the collimators and to determine the beam emittance. These investigations are interesting on single bunches, or bunch and batch families. The useful dynamic range in current over which good accuracy is required extends from 10¹¹ protons, the population of a nominal bunch, to a beam of 4.8 10¹⁴ protons, made of 2808 bunches at ultimate current; 40 MHz sampling is needed in order to investigate single bunches but not necessarily on consecutive bunches simultaneously.

4.3.3 LOCATION

When possible, the beam instruments are located in LSS4. This is a clean insertion and in addition the separation between the two beams is increased from the nominal value of 194 mm up to 431 mm in the region where the RF system is installed, Figure 2. This is also a good opportunity for a few instruments which otherwise would be difficult to incorporate.

For injection matching studies, it is suggested to place one TV monitor in each ring in the middle of the drift between quadrupoles Q5 and Q6, Figure 2. At this location the horizontal and vertical amplitude functions are both in the order of 200 m, hence rms values of 1.25 mm at 450 GeV will be measured. This screen can also be used for first turn studies, (section 4.2.1).

Based on the experience in LEP and in the SPS, two kinds of monitors are proposed to work on a circulating beam. They will guarantee some redundancy, which is highly useful, and the possibility of cross-calibration.

In each ring a synchrotron radiation monitor is investigated [4]. Dedicated superconducting undulators can be installed for this purpose upstream the D3 separator magnet, Figure 2. Their light signal can be extracted 10 m downstream D3, profiting from the beam deflection generated by the separator, and providing a 2D transverse image of the beam.

In addition, gas monitors are recommended exploiting either the rest gas ionisation signal or looking at the luminescence light resulting from de-excitation of the gas atoms [5,6]. For each beam one monitor with good resolution in each transverse plane is required. A location close to D3, Figure 2, where the separation between the beams is the largest and where the amplitude functions are bigger than 250 m is again favourable.

Wire scanners can withstand only a fraction of the nominal beam current [7]. However they are needed to calibrate at limited current these monitors and they will also be used for tail distribution studies. Hence they have also to be incorporated in this region. Due to their calibration function, they should provide data with a more demanding accuracy, better than 2%.



Figure 2: Configuration of transverse profile monitors in LSS4.



Figure 3: Telescope configuration in IR5.

Another monitor based on synchrotron radiation is recommended in LSS5 for beam size measurements at 7 TeV. It will use the light emitted by the beam within the separator magnet D2, extracted 20 m later, upstream quadrupole Q5, Figure 3. This monitor will provide the best resolution for the high energy operation on the collision optics, with amplitude functions of 590 m and 1600 m respectively in the horizontal and in the vertical planes.

4.4 IN THE DUMP LINES

The trajectory (average position) and dimensions (width and shape) of the extracted beam must be measured along the dump transfer lines from the entrance of the extraction septum up to the dump block input face. In particular, the function of the diluter magnets must be closely monitored to avoid damages from high current beams.

As a minimum, four dedicated monitors are required located upstream the extraction septum, upstream and downstream the diluter magnets and upstream the dump block.

The first one is still located in the ring. Hence, it will also serve for first turn studies, (section 4.2.1).

The dynamic range to be covered extends from the pilot bunch intensity, 5. 10⁹ protons, up to the ultimate current of a circulating beam, 4.8 10¹⁴ protons. The diagnostics should in principle be permanently available after any dump trigger whether requested, interlocked or erratic.

Single bunch sampling is in this case not essential and an accuracy of 100 μm is suitable.

5. FUNCTIONAL REQUIREMENTS

5.1 PERFORMANCE PARAMETERS

Table 2 summarises the required performances according to the various modes of operation.

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	Pilot pulse	Nominal/ultimate bunch	One batch or several batches
	5.10 p	1.1/1.7. 10 ¹¹ p	> 72 bunches
Transfer line:			
Accuracy			
on average position	100 µm	NR	NR
on rms value	100 µm	20 to 40 μm = 0.04 σ	20 to 40 μm = 0.04 σ
for TDI setting		σ _{TDI} ∕5=100 μm	< σ _{τDI} /5=100 μm
First turns (450 GeV)			individual bunch sampling
Accuracy on average position.	100 µm	NR	NR
on rms value	100 µm	100 µm	100 µm
Circulating beam Accuracy on rms value	100 µm	15 to 50 μm = 0.04 σ	<u>individual bunch sampling</u> 15 to 50 μm = 0.04 σ
tails		Amplitude <10 ⁻³ A _{MAX}	10 ⁻⁴ A _{MAX} , < Amplitude < 10 ⁻³ A _{MAX}
2D picture: coupling			
Dump lines	100	100	100
Accuracy on average position and rms value	100 µm	100 μm	100 μm
			SHALL WITHSTAND HIGH CURRENT

NR: not relevant – should be dealt with by BPM system

Table 3: Required accuracies, sensitivity and sampling mode

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5.2 SYNCHRONISATION

Measurements will be initiated by timing events like an injection pre-pulse or a start of ramp signal. It should also be possible to trigger them at any time via the control system.

5.3 DATA FLOW

5.4 AVAILABLE DATA

5.5 POST MORTEM

For post mortem analysis, data will be stored in two different buffers to be frozen by external events (triggers):

- one buffer containing the last data recorded on one turn
- another buffer with data recorded with lower time resolution.

6. DESIGN CONSTRAINTS

6.1 INSTALLATION

6.1.1 ALIGNMENT

6.1.2 IMPEDANCE

6.2 RADIATION HARDNESS

As far as radiation is concerned, the location in LSS5 is the most stringent, IP5 being a high luminosity insertion point. The expected activity in the detector region has been evaluated [8] and [9]. A dose between 10 Gy/year and 100 Gy/year is expected.

6.3 INB CONSTRAINTS

The LHC has been classified as an "Installation Nucleaire de Base" by the French Authorities. CERN is therefore obliged to conform to their relevant regulations, guidelines and procedures. Within this context CERN has to establish traceability & waste management procedures and maintain a radiological and zoning system. In order to meet these requirements, information such as: material content, location history, sub-assemblies, etc..., shall be supplied by the Contractor and will be maintained in a CERN database. CERN has created a set of procedures and conventions as part of the Quality Assurance System for LHC, which will also be used to facilitate these INB requirements. The relevant quality documents are listed below and shall be applied by the Contractor during the production, testing and assembly of components: "The Equipment Naming Convention", "The LHC Part Identification", "The Manufacturing and Test Folder".

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7. RELIABILITY, AVAILABILITY AND MAINTAINABILITY

The information provided by the monitor will contribute to clean machine operation. It is not intended for the time being to use it as an active element of interlock chains.

The profile monitors must be designed to offer reliable and continuous operation during the LHC running periods.

8. SAFETY AND REGULATORY REQUIREMENTS

The longitudinal profile monitor must meet the safety guidelines put forward by the CERN Technical Inspection and Safety Commission (TIS). TIS have issued safety documents in compliance with LHC-PM-QA-100 rev1.1, and the guidelines in these documents will be incorporated into the monitor design.

9. REFERENCES

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